

**Search Notes**

Application/Control No.

10/578,082

Examiner

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Applicant(s)/Patent under  
Reexamination

OHTSUJI, TAKAMASA

Art Unit

3747

**SEARCHED**

Class	Subclass	Date	Examiner
123	336	6/25/2007	HHH
123	337	6/25/2007	HHH
123	73A	6/25/2007	HHH
123	73AD	6/25/2007	HHH
123	398	6/25/2007	HHH
123	400	6/25/2007	HHH
123	442	6/25/2007	HHH

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East	6/25/2007	HHH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner